



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 28, 2026

IGI Report Number

DESCRIPTION

SHAPE AND CUTTING STYLE

MEASUREMENTS

GRADING RESULTS

CARAT WEIGHT

COLOR GRADE

CLARITY GRADE

ADDITIONAL GRADING INFORMATION

POLISH

SYMMETRY

FLUORESCENCE

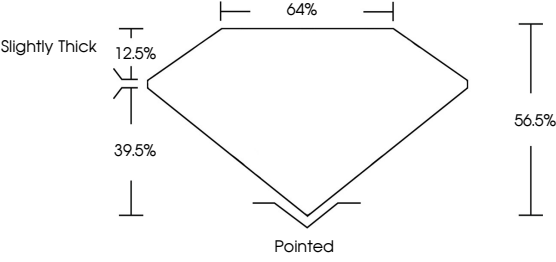
INSCRIPTION(S)

COMMENTS: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG842608810

Report verification at [igi.org](#)

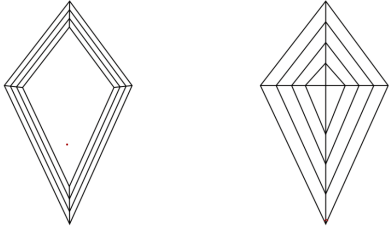
PROPORTIONS





Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

COLOR

CLARITY

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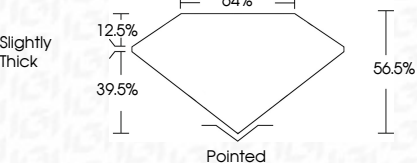
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PROPORTIONS



COLOR

CLARITY

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IGI Report No LG842608810

KITE STEP CUT

15.21 X 7.68 X 4.34 MM

2.52 CARATS

D

VVS 1

EXCELLENT

EXCELLENT

NONE

IGI LG842608810

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September 28, 2026

IGI Report No LG842608810

KITE STEP CUT

15.21 X 7.68 X 4.34 MM

2.52 CARATS

D

VVS 1

66.6%

64%

Slightly Thick

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG842608810

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